## EUROPEAN PATENT OFFICE

## **Patent Abstracts of Japan**

**PUBLICATION NUMBER** 

03235371

PUBLICATION DATE

21-10-91

APPLICATION DATE

10-02-90

APPLICATION NUMBER

02031204

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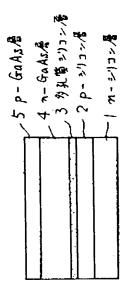
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TITLE

: MANUFACTURE OF TANDEM TYPE

**SOLAR BATTERY** 



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ABSTRACT: PURPOSE: To enable a solar battery of III-V group semiconductor developing less lattice defects on a silicon substrate to be formed for increasing the photoelectric conversion efficiency by making the surface of the silicon substrate porous for a silicon solar battery.

> CONSTITUTION: A single crystal silicon solar battery is composed of an n-silicon layer 1 and a p-silicon layer 2. Next, the substrate surface of said solar battery is anodized in fluoric acid solution making the surface porous to form a porous silicon layer 3. Next, an n-GaAs layer 4 and a p-GaAs layer 5 are formed on the layer 3 to manufacture the title tandem type solar battery. The photoelectric conversion efficiency of this solar battery is measured to be 27% so that the higher conversion efficiency than that of 24% of the solar battery formed by conventional process may be attained. That is, a compound semiconductor subject to less transposition and residual stress can be grown by making the topmost surface of a silicon substrate porous thereby enabling a high performance solar battery to be manufactured.

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